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Attorney Docket No. 108298738US
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Complete If Known	
Application Number	10/683,606-Conf. #1013
Filing Date	October 9, 2003
First Named Inventor	Garo J. Derderian
Art Unit	1762
Examiner Name	David P. Turocy
Attorney Docket Number	108298738US

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Examiner Initials*	Cite No.[1]	Document Number Number-Kind Code[2] (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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Examiner Name	David P. Turocy
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Application Number	10/683,606-Conf. #1013
Filing Date	October 9, 2003
First Named Inventor	Garo J. Derderian
Art Unit	1762
Examiner Name	David P. Turocy
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Art Unit	1762
Examiner Name	David P. Turocy
Attorney Docket Number	108298738US

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Examiner Name	David P. Turocy
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